

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Group Art Unit: 1753
Takeshi Nogami et al.)
Application No. 10/775,935) Confirmation No.: 3159
File: February 10, 2004)
For: SEMICONDUCTOR MANUFACTURING) Examiner: Luan V. Van
APPARATUS AND METHOD FOR)
MANUFACTURING SEMICONDUCTOR)
DEVICES)

MAIL STOP AFTER FINAL
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO DECEMBER 20, 2006 FINAL OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Final Office Action mailed December 20, 2006. Applicants respectfully request reconsideration of the application in view of this amendment and remarks herein.